



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
HAVING GATE OR TUNNEL INSULATION FILM**

Attorney Docket Number: **031140**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 28, 2006

Sir:

In response to the Office Action dated June 28, 2006, the response date of which having been extended by two months to November 28, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.